

<b>Notice of References Cited</b>	Application/Control No. 10/653,217		Applicant(s)/Patent Under Reexamination SATAKE ET AL.	
	Examiner Jaric Loving		Art Unit 2137	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0056546 A1	12-2001	Ogilvie, John W.L.	713/200
*	B	US-2002/0042880 A1	04-2002	Endoh, Tomoaki	713/182
*	C	US-2003/0041269 A1	02-2003	Kurishita et al.	713/201
*	D	US-2003/0044009 A1	03-2003	Dathathraya, Sridhar	380/55
*	E	US-6,571,147 B1	05-2003	Kashihara, Hideaki	700/100
*	F	US-2003/0099353 A1	05-2003	Goh et al.	380/51
*	G	US-6,671,564 B1	12-2003	Johnson et al.	700/19
*	H	US-2004/0008842 A1	01-2004	Partelow et al.	380/51
*	I	US-6,862,583 B1	03-2005	Mazzagatte et al.	705/64
*	J	US-6,952,780 B2	10-2005	Olsen et al.	726/26
*	K	US-7,100,198 B2	08-2006	Kurishita et al.	726/4
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.